



**The Abdus Salam
International Centre for Theoretical Physics**



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**Joint ICTP/IAEA Workshop on Advanced Simulation and Modelling
for Ion Beam Analysis**

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Introduction to Ion Beam Analysis: General Physics

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Introduction to Ion Beam Analysis: General Physics

M. Mayer

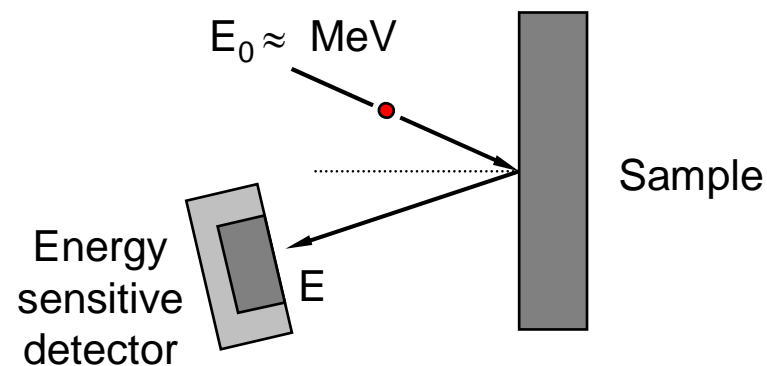
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- History of IBA
- Scattering kinematics
- Rutherford cross-section and beyond
- Stopping
- Energy spread:
 - Detector resolution
 - Energy straggling
 - Multiple scattering
- Depth resolution

IBA – Ion Beam Analysis

- Group of methods for the near-surface layer analysis of solids
- Elemental composition and depth profiling of individual elements
- Quantitative without reference samples
- No (or small) matrix effects
- Non-destructive
- Analysed depth: few 100 nm (heavy ions) to 40 μm (protons, high energy NRA)
- High sensitivity \approx ppm



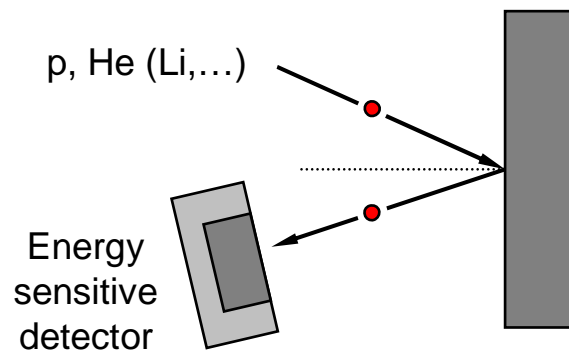
IBA methods: Detection of charged particles

Common for all IBA methods: Incident particles with ~MeV energies

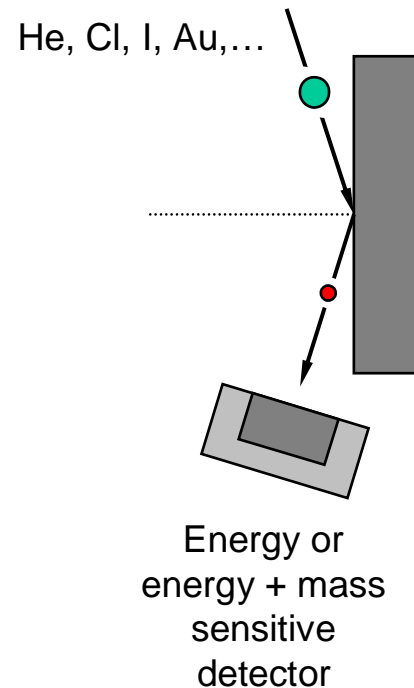
⇒ Methods can often be used in the same experimental setup

⇒ Methods can sometimes be used simultaneously

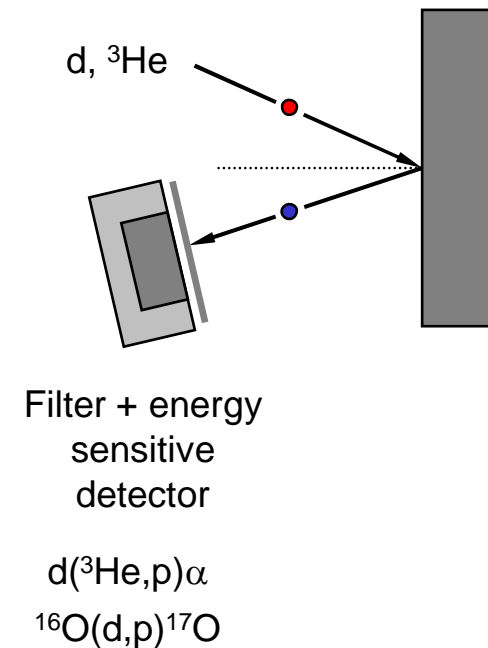
Rutherford backscattering (RBS)



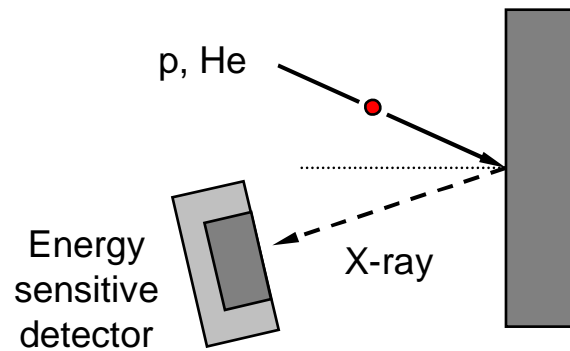
Elastic recoil detection analysis (ERDA)



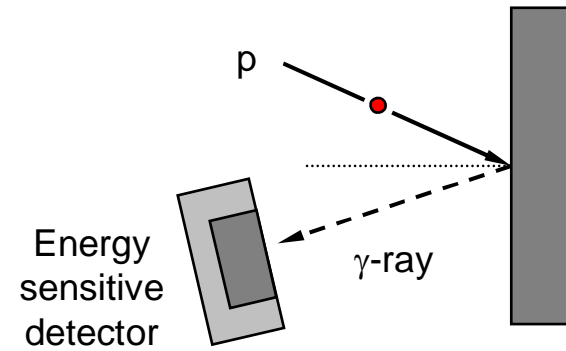
Nuclear reaction analysis (NRA)



Particle induced X-ray emission (PIXE)



Particle induced γ -ray emission (PIGE)



Ion beam Analysis (IBA) acronyms: G. Amsel, Nucl. Instr. Meth. B118 (1996) 52

Sir Ernest Rutherford (1871 - 1937)

- 1909: Rutherford's scattering experiments: ^4He on Au
⇒ Atomic nucleus, nature of the atom



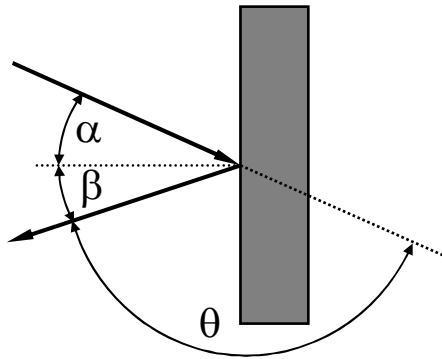
RBS as materials analysis method

- 1957: S. Rubin, T.O. Passell, E. Bailey, "Chemical Analysis of Surfaces by Nuclear Methods", *Analytical Chemistry* 29 (1957) 736

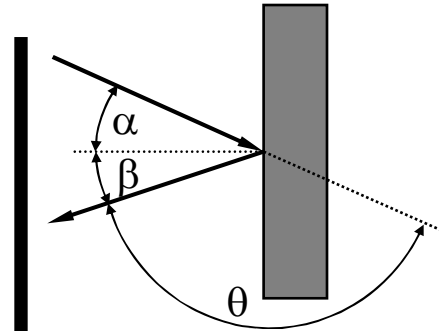
"Nuclear scattering and nuclear reactions induced by high energy protons and deuterons have been applied to the analysis of solid surfaces. The theory of the scattering method, and determination of O, Al, Si, S, Ca, Fe, Cu, Ag, Ba, and Pb by scattering method are described. C, N, O, F, and Na were also determined by nuclear reactions other than scattering. The methods are applicable to the detection of all elements to a depth of several μm , with sensitivities in the range of 10^{-8} to 10^{-6} g/cm^2 ."

- 1970's: RBS becomes a popular method due to invention of silicon solid state detectors (J.W. Mayer and B.R. Gossick 1956)
- 1976: J. L'Écuyer et al.
Invention of ERDA
- 1977 - 1979: Compilations of stopping power and cross-section data
H.H. Andersen and J.F. Ziegler, Stopping Powers of H, He in All Elements
R.A. Jarjis, Nuclear Cross Section Data for Surface Analysis
- 1977: J.W. Mayer and E. Rimini
Ion Beam Handbook for Materials Analysis
- 1985: M. Thompson
Computer code RUMP for analysis of RBS spectra
- since 1997: M. Mayer, N.P. Barradas
Advanced computer codes for analysis of RBS, ERDA, NRA spectra
- since 2003: Ion beam analysis nuclear data library (IBANDL)
<http://www-nds.iaea.org/ibandl/>

Scattering Geometry



α : incident angle
 β : exit angle
 θ : scattering angle



IBM geometry

Incident beam, exit beam,
surface normal in one plane

$$\Rightarrow \alpha + \beta + \theta = 180^\circ$$

Advantage: Simple

Cornell geometry

Incident beam, exit beam,
rotation axis in one plane

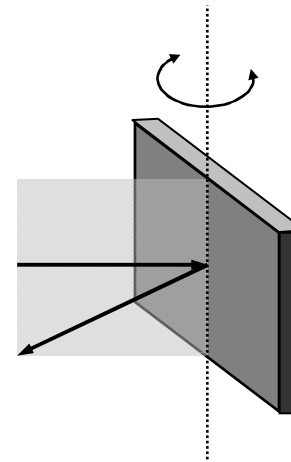
$$\Rightarrow \cos(\beta) = -\cos(\alpha) \cos(\theta)$$

Often used in RBS

Advantage:

large scattering angle and
grazing incident + exit angles

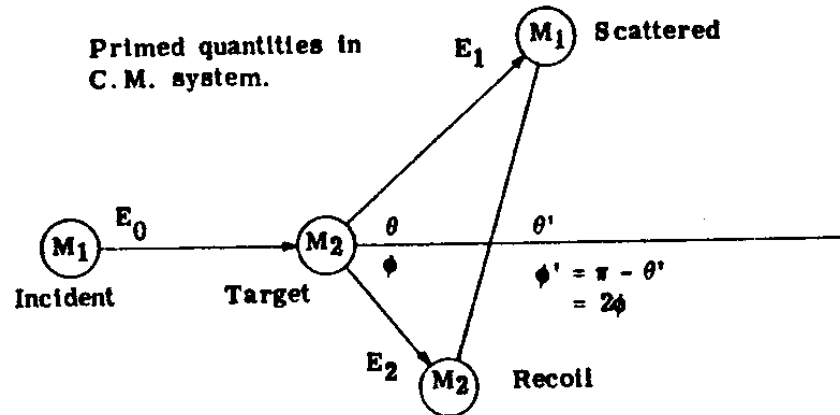
good mass and depth
resolution simultaneously



General geometry

α, β, θ not related

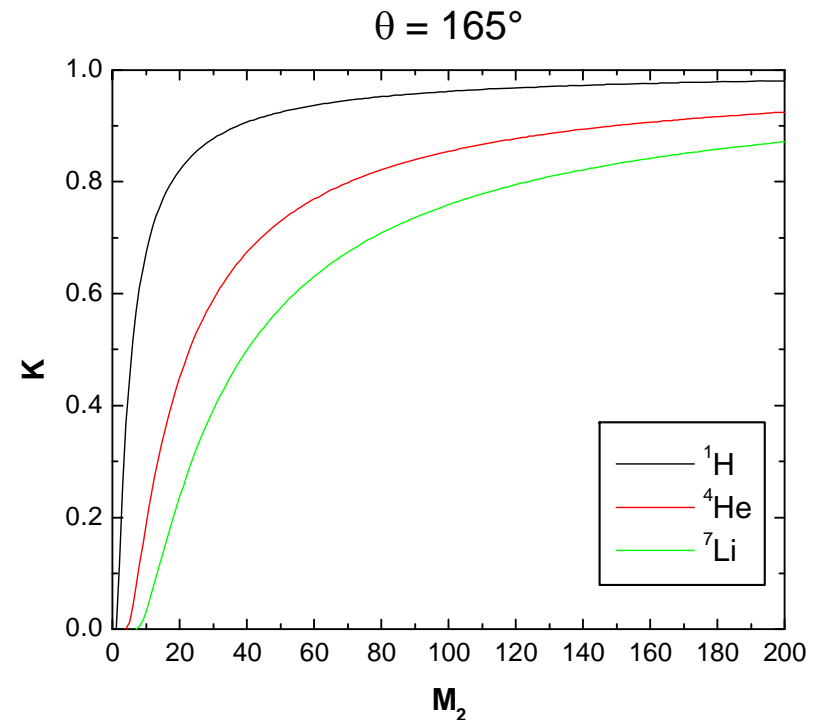
RBS: Scattering Kinematics



Elastic scattering: $E_0 = E_1 + E_2$

Kinematic factor: $E_1 = K E_0$

$$K = \left[\frac{(M_2^2 - M_1^2 \sin^2 \theta)^{1/2} + M_1 \cos \theta}{M_1 + M_2} \right]^2$$



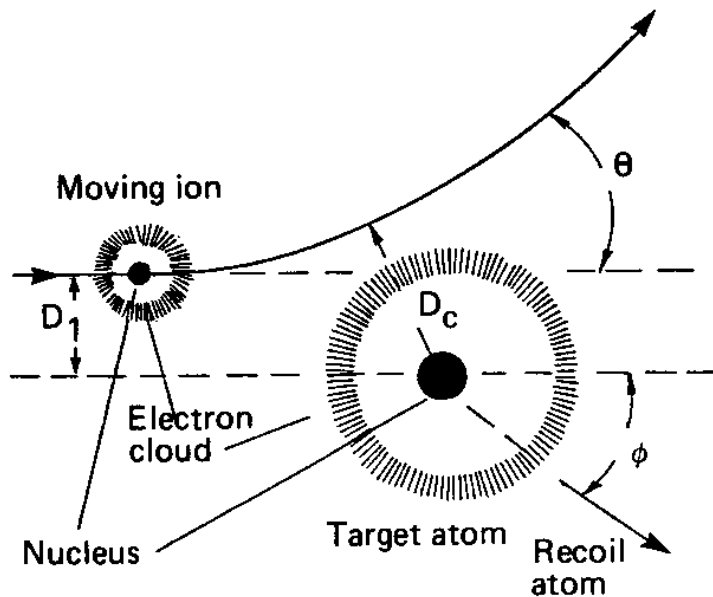
$$\Delta E_1 = E_0 \frac{dK}{dM_2} \Delta M_2$$

ΔE_1 : Energy separation

ΔM_2 : Mass difference

⇒ Decreased mass resolution for heavier elements

Rutherford Cross Section



- Neglect shielding by electron clouds
 - Distance of closest approach large enough that nuclear force is negligible
- ⇒ Rutherford scattering cross section

$$\sigma_R(E, \theta) = \left(\frac{Z_1 Z_2 e^2}{4E} \right)^2 \times \frac{4 \left[\left(M_2^2 - M_1^2 \sin^2 \theta \right)^{1/2} + M_2 \cos \theta \right]^2}{M_2 \sin^4 \theta \left(M_2^2 - M_1^2 \sin^2 \theta \right)^{1/2}}$$

Note that: $\sigma_R \propto \frac{Z_1^2 Z_2^2}{E^2}$

Sensitivity increases with

- increasing Z_1
- increasing Z_2
- decreasing E

Shielded Rutherford Cross Section



Shielding by electron clouds gets important at

- low energies
- low scattering angles
- high Z_2

Shielding is taken into account by a shielding factor $F(E, \theta)$

$$\sigma(E, \theta) = F(E, \theta) \sigma_R(E, \theta)$$

$F(E, \theta)$ close to unity

$F(E, \theta)$ is obtained by solving the scattering equations for a shielded interatomic potential:

$$V(r) = \frac{Z_1 Z_2 e^2}{r} \varphi(r/a)$$

φ : Screening function

Use Thomas-Fermi or Lenz-Jenssen screening function

a : Screening radius $a = 0.885 a_0 (Z_1^{2/3} + Z_2^{2/3})^{-1/2}$

a_0 : Bohr radius

Shielded Rutherford Cross Section (2)



For $90^\circ \leq \theta \leq 180^\circ$:

L'Ecuyer et al. (1979)

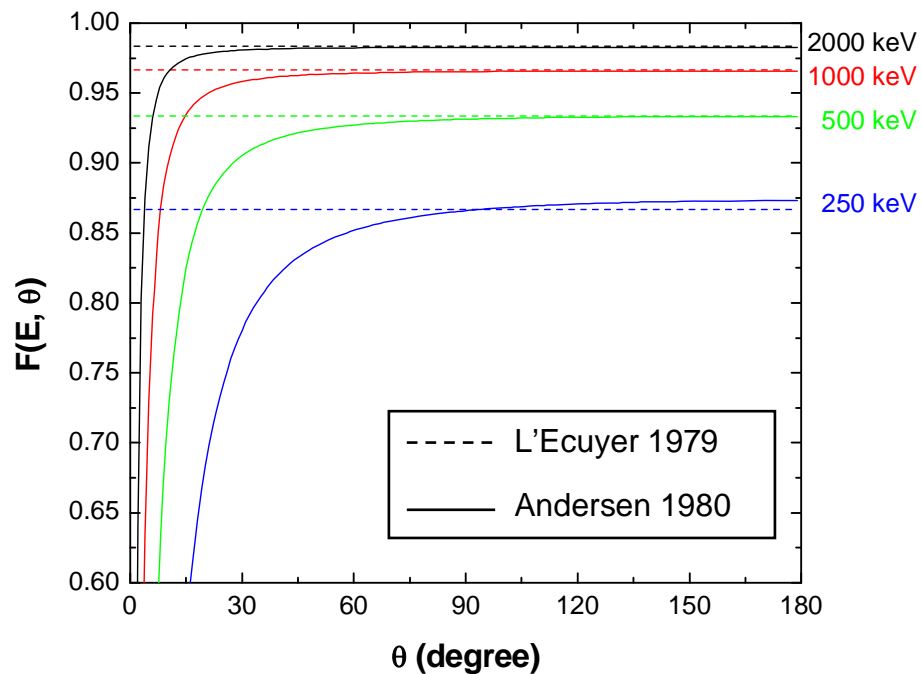
$$\frac{\sigma}{\sigma_R} = 1 - \frac{0.049 Z_1 Z_2^{4/3}}{E_{CM}}$$

Wenzel and Whaling (1952)

$$\frac{\sigma}{\sigma_R} = 1 - \frac{0.0326 Z_1 Z_2^{7/2}}{E_{CM}}$$

For all θ : Andersen et al. (1980)

^4He backscattered from Au



Non-Rutherford Cross Section



Cross section becomes non-Rutherford if nuclear forces get important

- high energies
- high scattering angles
- low Z_2

Energy at which the cross section deviates by $> 4\%$ from Rutherford at $160^\circ \leq \theta \leq 180^\circ$

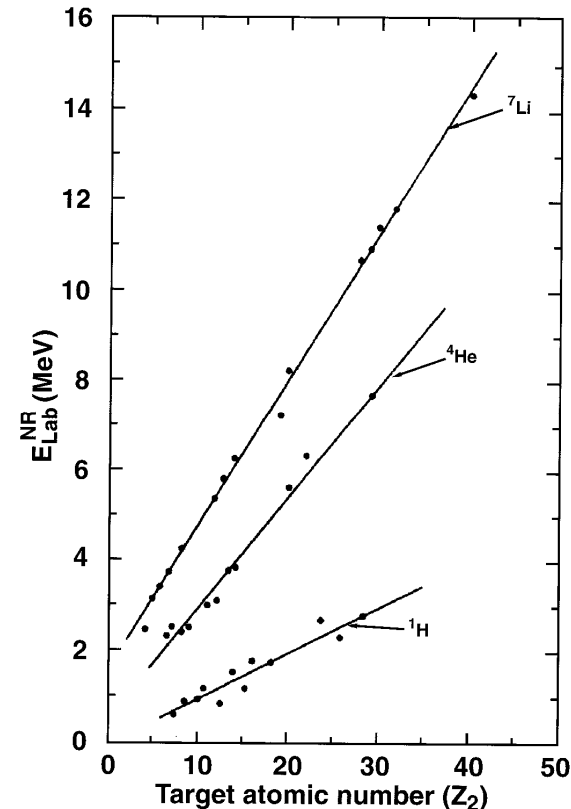
Bozoian (1991)

$${}^1\text{H}: E_{\text{Lab}}^{\text{NR}} = 0.12 Z_2 - 0.5 \quad [\text{MeV}]$$

$${}^4\text{He}: E_{\text{Lab}}^{\text{NR}} = 0.25 Z_2 + 0.4 \quad [\text{MeV}]$$

Linear Fit to experimental values (${}^1\text{H}$, ${}^4\text{He}$)
or optical model calculations (${}^7\text{Li}$)

Accurate within ± 0.5 MeV



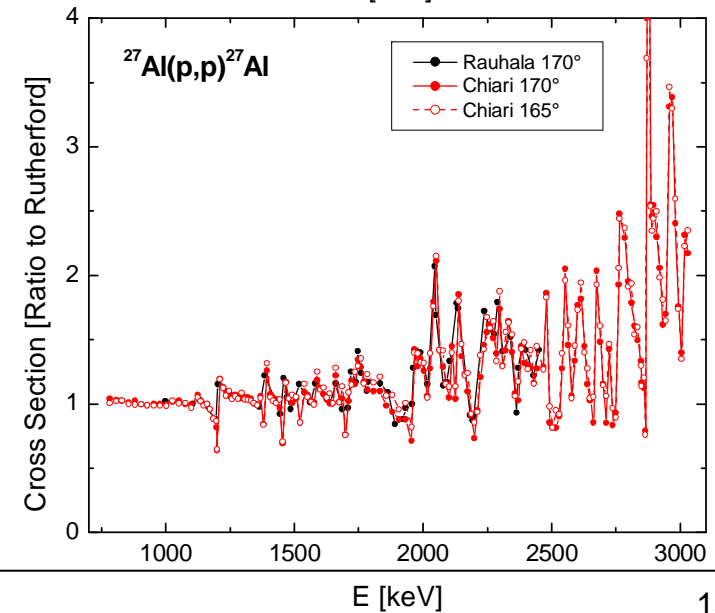
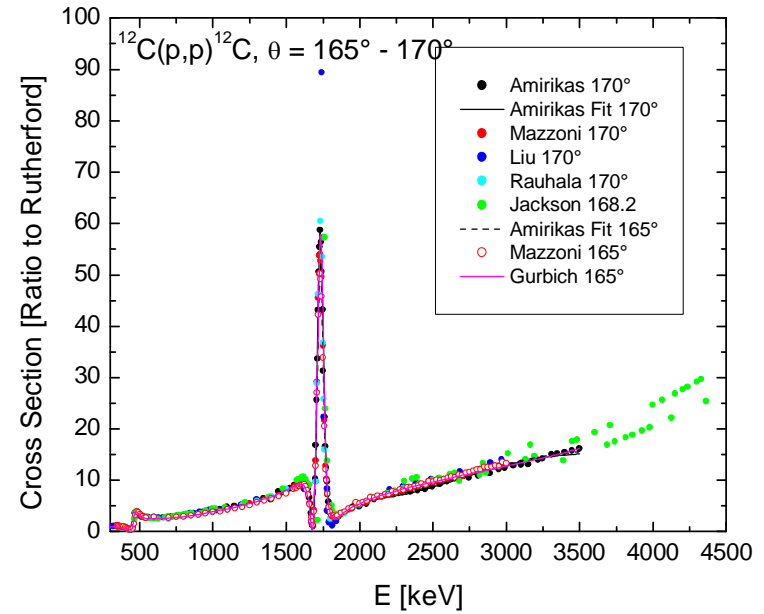
J.R. Tesmer and M. Nastasi,
Handbook of Modern Ion Beam Materials Analysis,
MRS, 1995

Non-Rutherford Cross Section (2)



Deviations from Rutherford may be huge

⇒ Carefully check for possible deviations from Rutherford



Stopping Power



⁴He in Ni

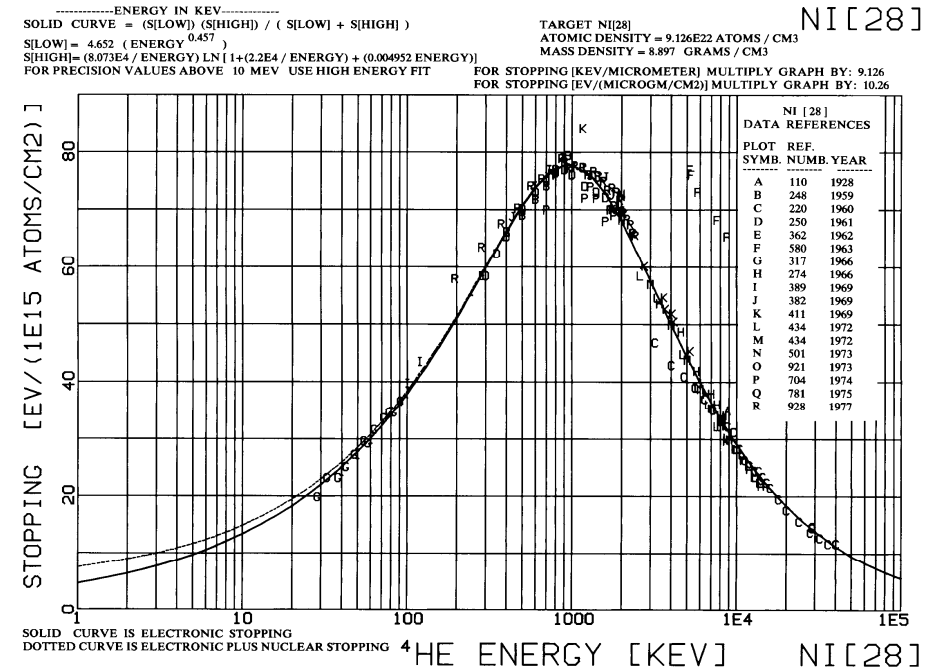
NI[28]

- **Electronic stopping power:**

- Andersen, Ziegler (1977):
H, He in all elements
- Ziegler, Biersack, Littmarck (1985):
All ions in all elements
- Several SRIM-versions since then
- Additional work by Kalbitzer, Paul, ...
- Accuracy: 5% for H, He
10% for heavy ions

- **Nuclear stopping power:**

- Only important for heavy ions
or low energies
- Ziegler, Biersack, Littmarck (1985):
All ions in all elements using ZBL potential



J.F. Ziegler, Helium - Stopping Powers and Ranges in All Elements, Vol. 4, Pergamon Press, 1977

Stopping Power (2)



Stopping in compounds:

consider compound $A_m B_n$, with $m + n = 1$

S_A is stopping power in element A

S_B is stopping power in element B

What is stopping power S_{AB} in compound?

Bragg's rule (Bragg and Kleeman, 1905):

$$S_{AB} = m S_A + n S_B$$

Bragg's rule is accurate in:

- Metal alloys

Bragg's rule is inaccurate (up to 20%) in:

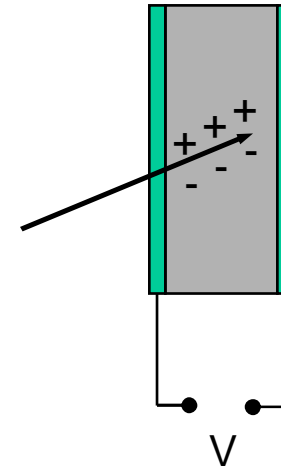
- Hydrocarbons
- Oxides
- Nitrides
- ...

Other models for compounds

- Hydrocarbons:
 - Cores-and-Bonds (CAB) model
 - Ziegler, Manoyan (1988)
 - Contributions of atomic cores and chemical bonds between atoms
- Large number of experimental data, especially for hydrocarbons, plastics, ...

Principle of operation:

- Creation of electron-hole pairs by charged particles
- Separation of electron-hole pairs by high voltage V
 - \Rightarrow Number of electron-hole pairs \propto Particle energy
 - \Rightarrow Charge pulse \propto Particle energy



Limited energy resolution due to:

- Statistical fluctuations in energy transfer to electrons and phonons
- Statistical fluctuations in annihilation of electron-hole pairs

Additional energy broadening due to:

- Preamplifier noise
- Other electronic noise

Silicon Detector Resolution (2)

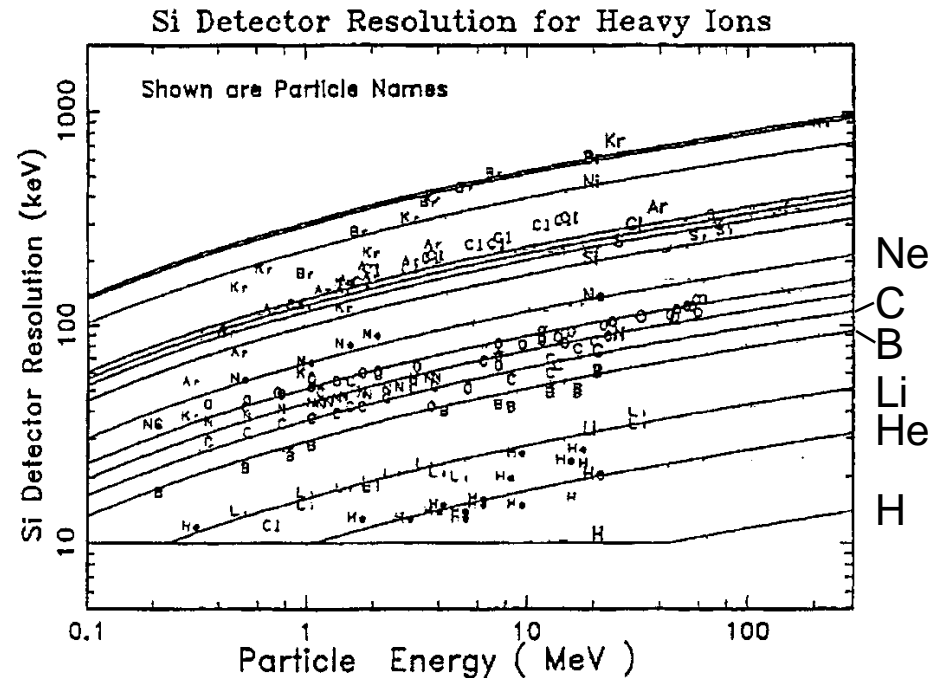


Typical values (FWHM):

- H 2 MeV: 10 keV
- He 2 MeV: 12 keV
- Li 5 MeV: 20 keV

Ad-hoc fit to experimental data:

$$\begin{aligned} & \text{FWHM resolution (keV)} \\ &= C_1(Z_i)^{C_2}(\ln E_{\text{keV}})^{C_3} - C_4(Z_i)^{C_5}/(\ln E_{\text{keV}})^{C_6} \\ C_n &= 0.0999288, 1.1871, 1.94699, 0.18, 2.70004, \\ & 9.29965 \end{aligned}$$



J.F. Ziegler, Nucl. Instr. Meth. B136-138 (1998) 141

Better energy resolution for heavy ions can be obtained by:

- Electrostatic analyser (Disadvantage: large)
- Magnetic analyser (Disadvantage: large)
- Time-of-flight (Disadvantage: length, small solid angle)

Slowing down of ions in matter is accompanied by a spread of beam energy

⇒ **energy straggling**

- **Electronic energy loss straggling** due to statistical fluctuations in the transfer of energy to electrons
- **Nuclear energy loss straggling** due to statistical fluctuations in the nuclear energy loss
- **Geometrical straggling** due to finite detector solid angle and finite beam spot size
- **Multiple small angle scattering**

Electronic Energy Loss Straggling



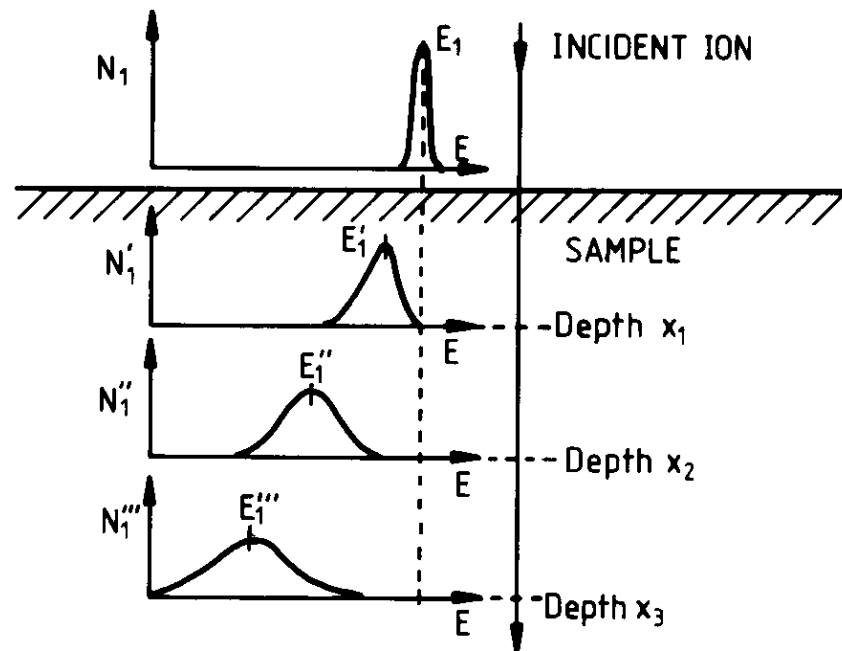
Due to **statistical fluctuations** in the transfer of energy to electrons
⇒ statistical fluctuations in energy loss

Energy after penetrating a layer Δx : $\langle E \rangle = E_0 - S \Delta x$

$\langle E \rangle$ mean energy

S stopping power

⇒ **only applicable for mean energy of many particles**

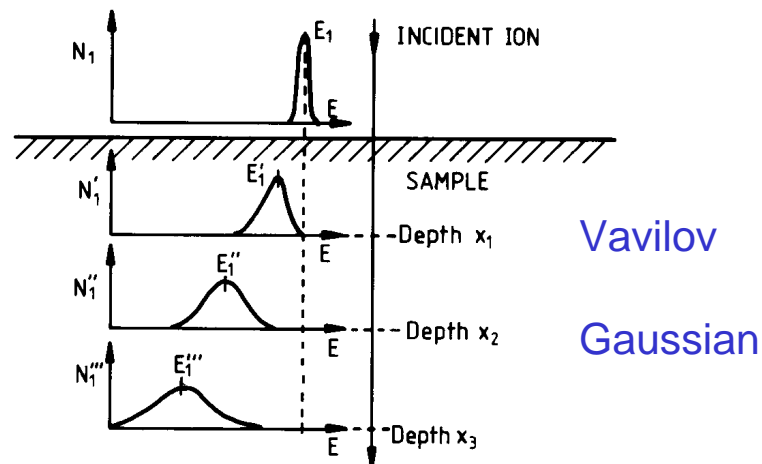


Electronic Energy Loss Straggling (2)



Shape of the energy distribution?

$\Delta E/E_0$	Theory	Characteristics
< 10%	Vavilov theory	Low number of ion-electron collisions Non-Gaussian
10% – 20%	Bohr theory	Large number of ion-electron collisions Gaussian
20% – 50%	Symon, Tschalär theory	Non-stochastic broadening due to stopping Almost Gaussian
50% – 90%	Payne, Tschalär theory	Energy below stopping power maximum Non stochastic squeezing due to stopping Non-Gaussian



Vavilov 1957

P.V. Vavilov, Soviet Physics J.E.T.P. **5** (1957) 749

Valid for small energy losses

⇒ Low number of ion-electron collisions

⇒ Non-Gaussian energy distribution with tail towards low energies



Mostly replaced by Bohr's theory and approximated by Gaussian distribution

⇒ Total energy resolution near the surface usually dominated by detector resolution due to small energy loss straggling

⇒ Only necessary in high resolution experiments

Bohr 1948

N. Bohr, Mat. Fys. Medd. Dan. Vid. Selsk. **18** (1948)

Valid for intermediate energy losses

⇒ Large number of ion-electron collisions

⇒ Gaussian energy distribution

Approximations in Bohr's theory:

- Ions penetrating a gas of free electrons
- Ions are fully ionised
- Ion velocity \gg electron velocity \Rightarrow stationary electrons
- Stopping power effects are neglected

$$\sigma_{Bohr}^2 = 0.26 Z_1^2 Z_2 \Delta x$$

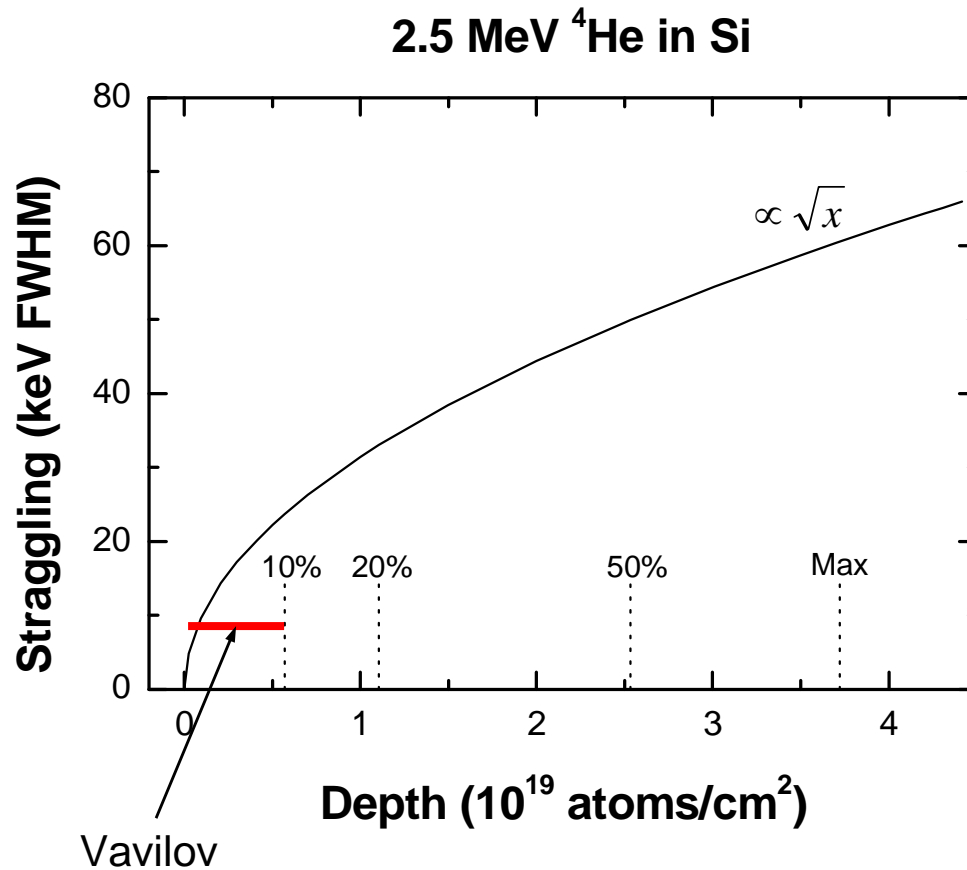
σ_{Bohr}^2 variance of the Gaussian distribution [keV²]

Δx depth [10^{18} atoms/cm²]

Z_1 atomic number of incident ions

Z_2 atomic number of target atoms

Bohr Theory: Example



Improvements to Bohr Theory



Chu 1977

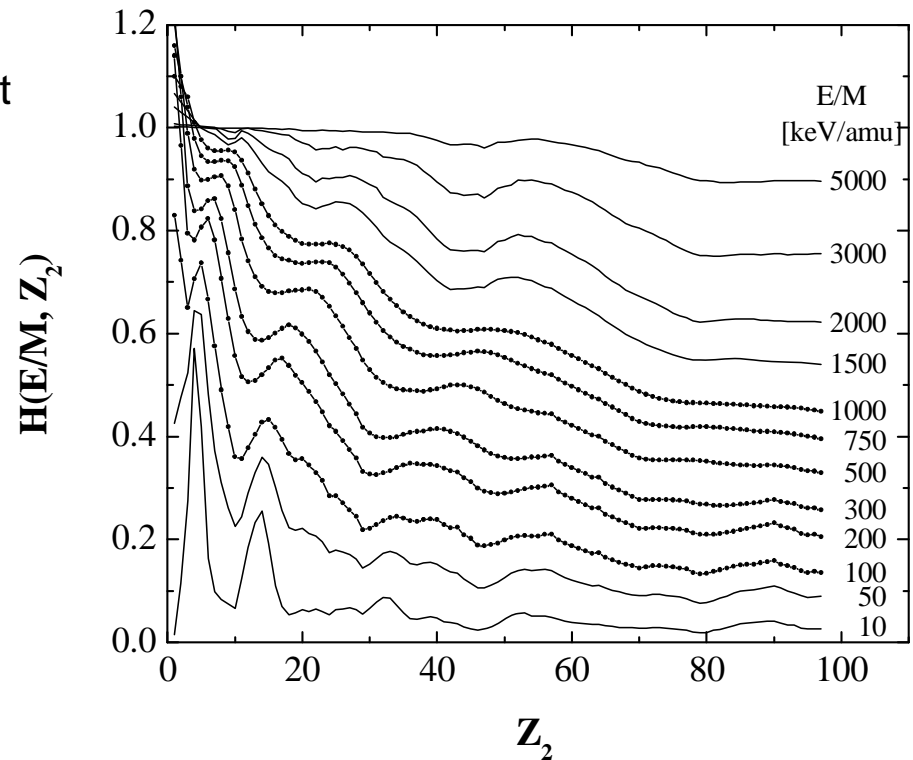
J.W. Mayer, E. Rimini, Ion Beam Handbook for Material Analysis, 1977

Approximations in Chu's theory:

- Binding of electrons is taken into account
- Hartree-Fock electron distribution
- Stopping power effects are neglected

$$\sigma_{Chu}^2 = H\left(\frac{E}{M_1}, Z_2\right) \sigma_{Bohr}^2$$

⇒ Smaller straggling than Bohr



Additive rule proposed by Chu 1977

J.W. Mayer, E. Rimini, Ion Beam Handbook for Material Analysis, 1977

consider compound $A_m B_n$, with $m + n = 1$

σ_A^2 is variance of straggling in element A

σ_B^2 is variance of straggling in element B

$$\sigma_{AB}^2 = \sigma_A^2 + \sigma_B^2$$

σ_A^2 Straggling in element A in a layer $m \Delta x$

σ_B^2 Straggling in element B in a layer $n \Delta x$

Propagation of Straggling in Thick Layers

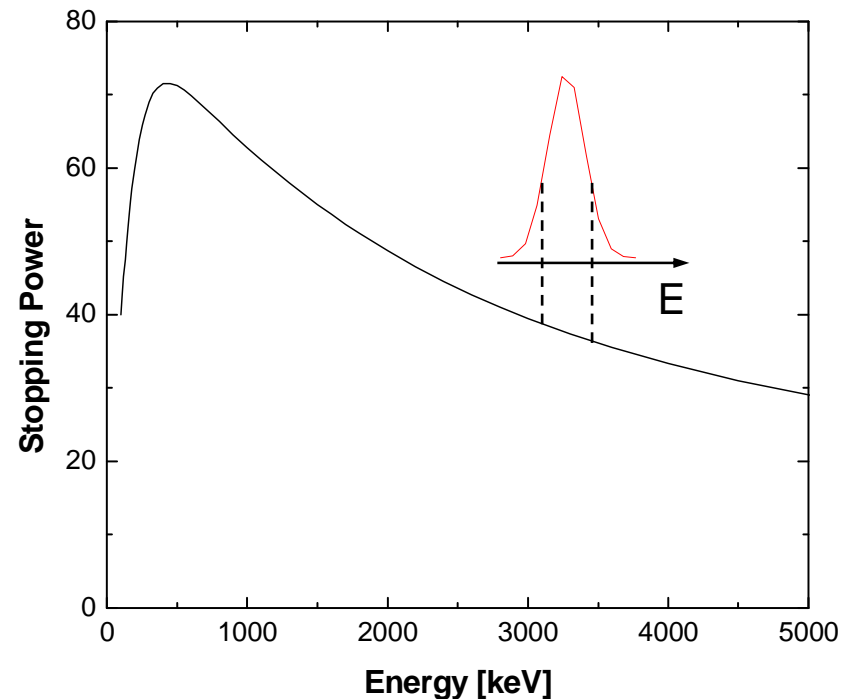


Consider particles with energy distribution

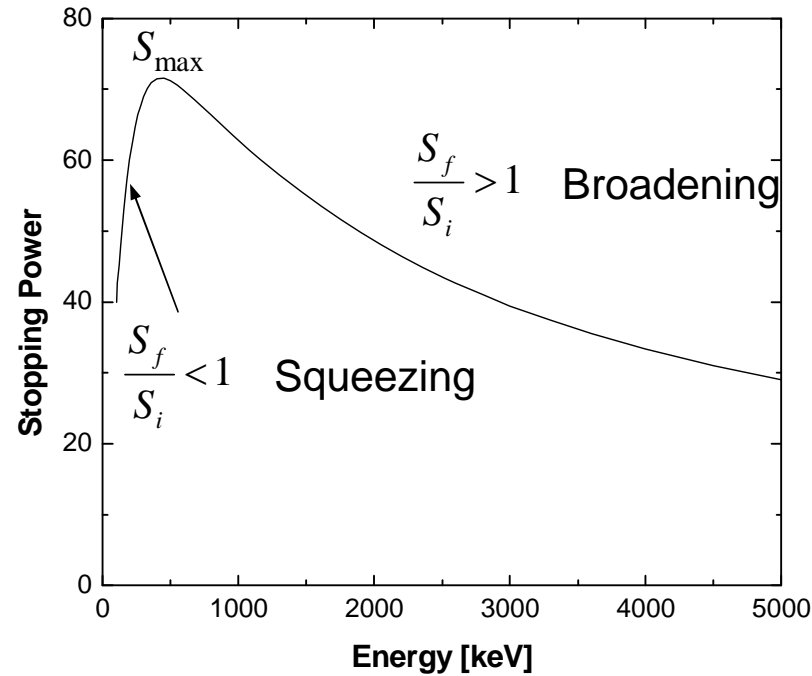
- **Energy above stopping power maximum**
higher energetic particles \Rightarrow smaller stopping
 \Rightarrow non-stochastic broadening
- **Energy below stopping power maximum**
higher energetic particles \Rightarrow larger stopping
 \Rightarrow non-stochastic squeezing

C. Tschalär, Nucl. Instr. Meth. **61** (1968) 141

M.G. Payne, Phys. Rev. **185** (1969) 611



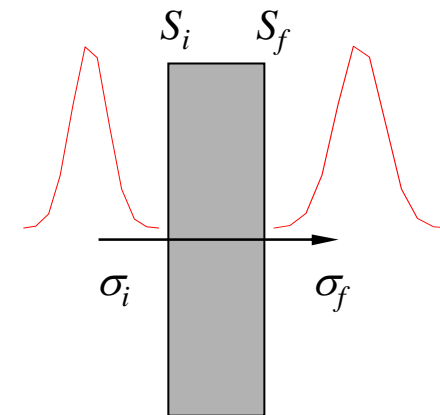
Propagation of Straggling in Thick Layers (2)



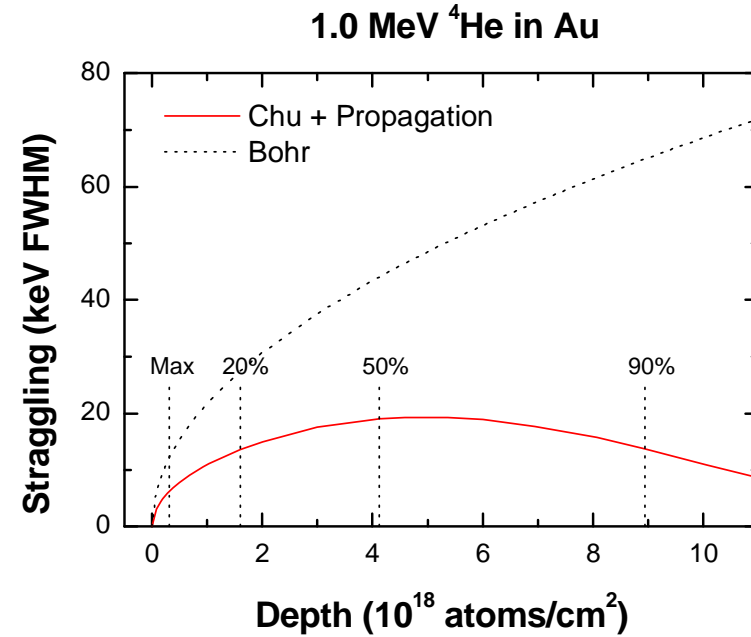
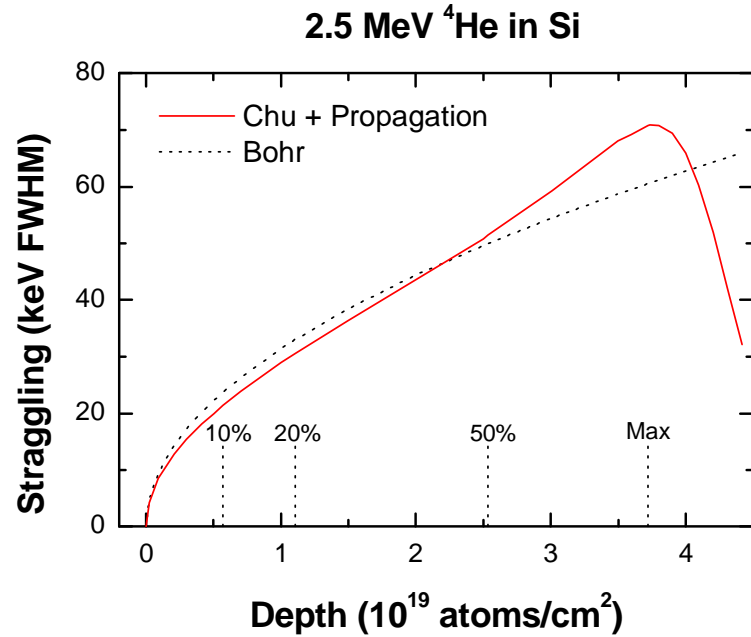
Adding stochastic and non-stochastic effects:

- Statistically independent

$$\sigma_f^2 = \left(\frac{S_f}{S_i} \right)^2 \sigma_i^2 + \sigma_{Chu}^2$$



Propagation of Straggling: Examples



$$\sigma_f^2 = \left(\frac{S_f}{S_i} \right)^2 \sigma_i^2 + \sigma_{Chu}^2$$

Multiple and Plural Scattering

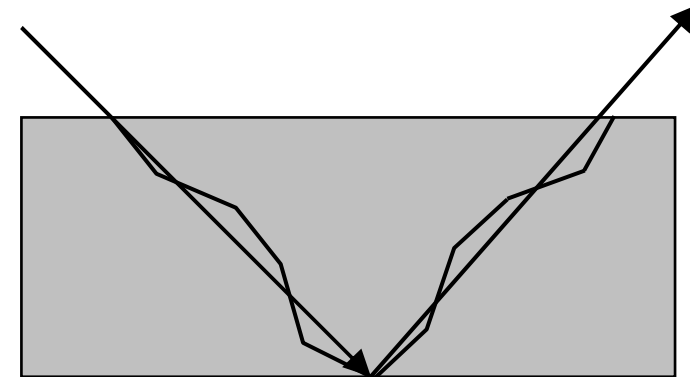


Multiple small angle deflections

- Path length differences on ingoing and outgoing paths
⇒ energy spread
- Spread in scattering angle
⇒ energy spread of starting particles

P. Sigmund and K. Winterbon, Nucl. Instr. Meth. **119** (1974) 541

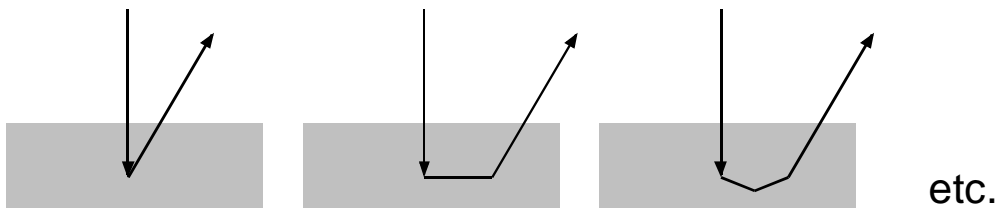
E. Szilagy et al., Nucl. Instr. Meth. **B100** (1995) 103



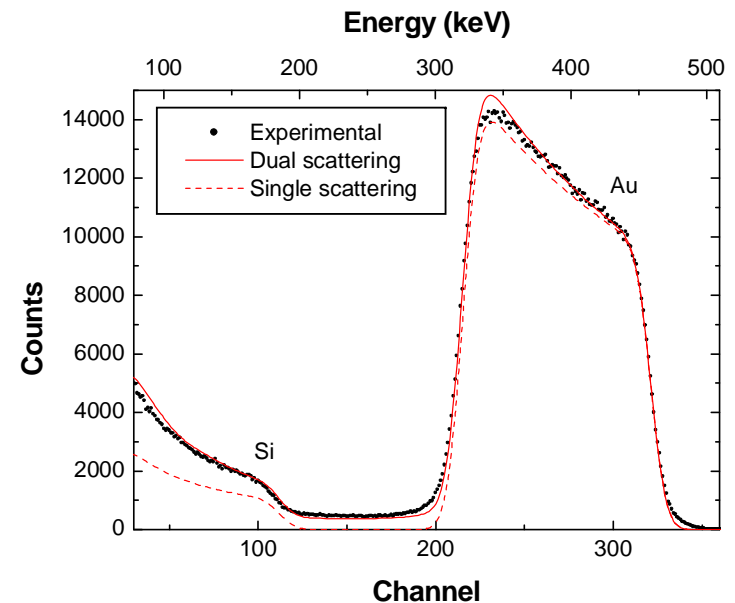
Large angle deflections (Plural scattering)

- For example: Background below high-Z layers

W. Eckstein and M. Mayer, Nucl. Instr. Meth. **B153** (1999) 337



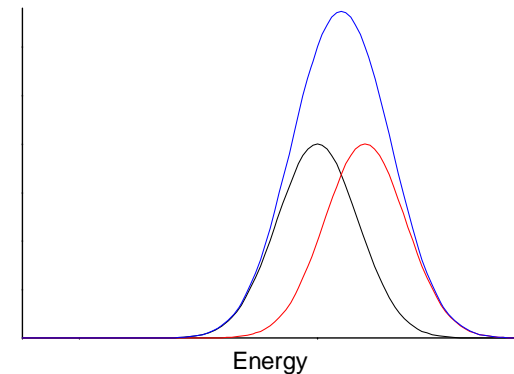
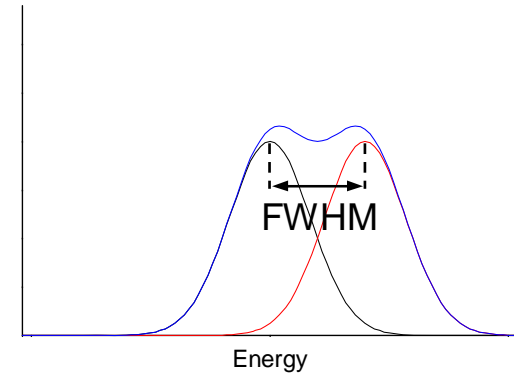
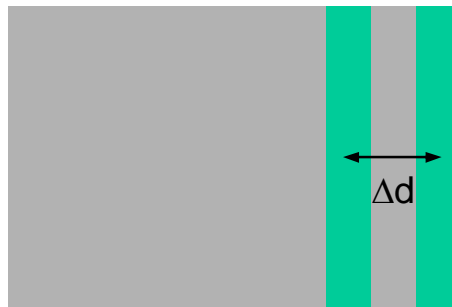
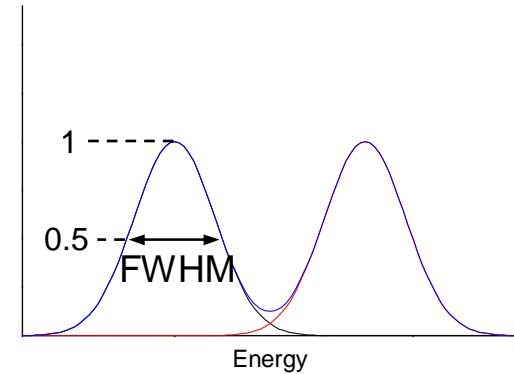
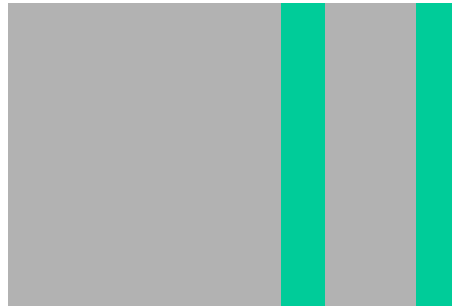
500 keV ^4He , 100 nm Au on Si, $\theta = 165^\circ$



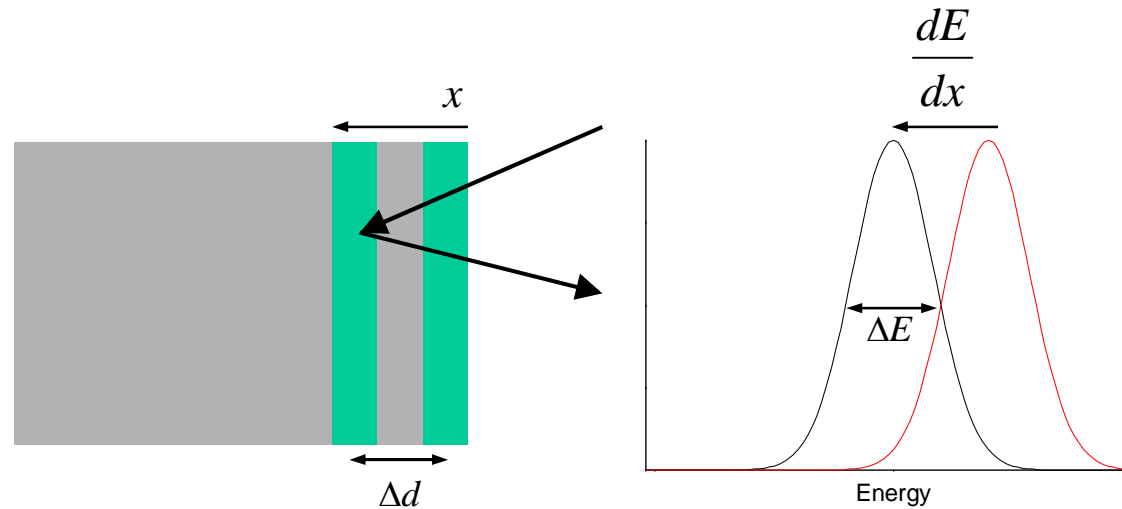
Depth resolution

- Depth resolution Δd :
Distance between 2 layers,
so that their energy separation is
identical to the energy spread
- Energy spread is measured
in FWHM
⇒ Depth resolution in FWHM

It is not possible to obtain information about the depth profile better than the depth resolution



Depth resolution (2)



$$S_{eff} = \left| \frac{dE}{dx}(x) \right|$$

S_{eff} : Effective stopping power
 E : Mean energy in detector
 x : Depth

$$\Delta d(x) = \frac{\Delta E(x)}{S_{eff}(x)}$$

ΔE : Energy straggling

- **IBA: Group of methods** for the near-surface layer analysis of solids
Charged particles or photons can be detected
- **Scattering kinematics**: Mass resolution
- **Stopping power**: Depth resolution
- **Rutherford cross-section**: Shielding by electrons; non-Rutherford at high energies
- **Silicon detector**: Limited energy resolution
- **Energy spread** due to
Energy-loss straggling + propagation in thick layers
Multiple small-angle scattering; Plural scattering
- **Limited depth resolution** due to effective stopping power + energy spread